

<b>Notice of References Cited</b>	Application/Control No. 10/792,233		Applicant(s)/Patent Under Reexamination ZIMNIEWICZ ET AL.	
	Examiner Raymond J. Bayerl		Art Unit 2174	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0110241	06-2003	Cheng et al.	717/176X
*	B	US-2005/0172283	08-2005	Delo, John C.	717/174
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
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**FOREIGN PATENT DOCUMENTS**

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